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Docket No.: 50395-253

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
	:	
Masashi ONISHI, et al.	:	Confirmation Number: 3211
	:	
Serial No.: 10/780,716	:	Group Art Unit: 3742
	:	
Filed: February 19, 2004	:	Examiner:
	:	

For: GLASS-PROCESSING METHOD AND GLASS-PROCESSING APPARATUS FOR  
THE METHOD

**INFORMATION DISCLOSURE STATEMENT**

Mail Stop IDS  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

10/780,716

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

A handwritten signature in dark ink, appearing to read 'A. J. Steiner', is written over the printed name.

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## INFORMATION DISCLOSURE CITATION IN AN APPLICATION

ATTY. DOCKET NO.  
50395-253

SERIAL NO.  
10/780,716

APPLICANT  
**Masashi ONISHI, et al.**

FILING DATE  
**February 19, 2004**

GROUP  
3742

(PTO-1449)

## U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number & -Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
		JP 2818735	08/21/1998	AT&T CORP.	Corresponds with US Patent 5,397,372		x
		EP 0 216 338 A2	09/20/1986	POLAROID CORPORATION		x	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)
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EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
		"2.1 RF Induced Thermal Plasma Process.", The R&D Review of Toyota CRDL (Toyota central R&D Labs), Volume 29, Number 3, (1994.9), pp. 61-69 and partial English Translation thereof.

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.